



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
 UNITED STATES PATENT AND TRADEMARK OFFICE
 WASHINGTON, D.C. 20231
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Bib Data Sheet

CONFIRMATION NO. 8690

SERIAL NUMBER 09/761,738	FILING DATE 01/18/2001 RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 202009US-2 DIV
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APPLICANTS

Shigenobu Maeda, Tokyo, JAPAN;

**** CONTINUING DATA *******

THIS APPLICATION IS A DIV OF 09/349,514 07/09/1999 PAT 6,231,673

**** FOREIGN APPLICATIONS *******

JAPAN P11-14303 01/22/1999

IF REQUIRED, FOREIGN FILING LICENSE

GRANTED ** 04/25/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 36	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged		Initials			

ADDRESS

22850

TITLE

Manufacturing method of semiconductor wafer, semiconductor manufacturing apparatus, and semiconductor device

FILING FEE RECEIVED 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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SERIAL NUMBER 09/761,738	FILING DATE 01/18/2001 RULE	CLASS 438	GROUP/ART UNIT 2824	ATTORNEY DOCKET NO. 202009US-2 DIV
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APPLICANTS

Shigenobu Maeda, Tokyo, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 09/349,514 07/09/1999 PAT 6,231,673

MR

** FOREIGN APPLICATIONS *****

JAPAN P11-14303 01/22/1999

BSR

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/25/2001

Foreign Priority claimed §5 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Arrangement	STATE OR COUNTRY JAPAN	SHEETS DRAWING 36	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 1
Verified and Acknowledged Examiner's Signature	Initials				

ADDRESS

22850
 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.
 1940 DUKE STREET
 ALEXANDRIA, VA
 22314

TITLE

MANUFACTURING METHOD OF CIRCUIT ELEMENTS ON A SEMICONDUCTOR WAFER USING A PLURALITY OF MASKS

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees. <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
RECEIVED		



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APPLICANTS

Shigenobu Maeda, Tokyo, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 09/349,514 07/09/1999 PAT 6,231,673

MSL

** FOREIGN APPLICATIONS *****

JAPAN P11-14303 01/22/1999

MSL

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/25/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 36	4	1
Verified and Acknowledged	<i>MSL</i> Examiner's Signature	Initials			

ADDRESS

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TITLE

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FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____
RECEIVED 710		